



Mareen R Datema

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Publications (3)

Fernández-Rivas M, Gómez García I, Gonzalo-Fernández A, Fuentes Ferrer M, Dölle-Bierke S, Marco-Martín G, Ballmer-Weber B, Asero R, Belohlavkova S, Beyer K, de Blay F, Clausen M, Datema M, Dubakiene R, Grimshaw K, Hoffmann-Sommergruber K, Hourihane J, Jedrzejczak-Czechowicz M, Knulst A, Kralimarkova T, Le T, Papadopoulos N, Popov T, Poulsen L, Purohit A, Seneviratne S, Simpson A, Sinaniotis A, Turkalji M, Vázquez-Cortés S, Vera-Berrios R, Muraro A, Worm M, Roberts G, Van Ree R, Fernández-Perez C, Turner P, Mills E. Development and validation of the food allergy severity score. *Allergy* 2021; 77:1545-1558.

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Lyons S, Pontoppidan B, Popov T, Prado N, Purohit A, Reig I, Seneviratne S, Sinaniotis A, Vassilopoulou E, Versteeg S, Vieths S, Zwinderman A, Welsing P, Mills E, Ballmer-Weber B, Knulst A, Fernández-Rivas M, Papadopoulos N, Lidholm J, Datema M, Le T, Asero R, Barreales L, Belohlavkova S, de Blay F, Clausen M, Dubakiene R, Fernández-Perez C, Fritsche P, Gislason D, Hoffmann-Sommergruber K, Jedrzejczak-Czechowicz M, Jongejan L, Kowalski M, Kralimarkova T, Van Ree R. Walnut Allergy Across Europe: Distribution of Allergen Sensitization Patterns and Prediction of Severity. *J Allergy Clin Immunol Pract* 2020

Projects (0)

No results found.

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